

Search Notes 	Application/Control No. 10/734,997	Applicant(s)/Patent under Reexamination KIM ET AL.
	Examiner Khai Tran	Art Unit 2611

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
375	222,376	5/24/07	LLT
	223,316		
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379	406.08		